

U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE  <b>SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT</b> (Use several sheets if necessary)	ATTY. DOCKET NO. <b>690121.406USPC</b>	APPLICATION NO. <b>10/577,538</b>
	APPLICANTS <b>Takayuki Shima et al.</b>	
	INT'L FILING DATE <b>October 27, 2004</b>	GROUP ART UNIT <b>2627</b>

**U.S. PATENT DOCUMENTS**

*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						

**FOREIGN PATENT DOCUMENTS**

		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION	
					YES	NO
	AI					
	AJ					
	AK					
	AL					

**OTHER PRIOR ART** (Including Author, Title, Date, Pertinent Pages, Etc.)

	AM	Chiu, Yi et al., "Fabrication and Nonlinear Optical Properties of Nanoparticle Silver Oxide Films," <i>J. App. Phys.</i> , 94(3):1996-2001, August 1, 2003.
	AN	Liu, Wei-Chih et al., "Near-field Images of the AgOx-type Super-resolution Near-field Structure," <i>App. Phys. Letters</i> , 78(6):685-687, February 5, 2001.
	AO	Liu, Wei-Chih and Ding Ping Tsai, "Nonlinear Near-Field Optical Effects of the AgOx-Type Super-Resolution Near-Field Structure," <i>Jpn. J. of App. Phys.</i> , 42:1031-1032, February 2003.
	AP	Tominaga, J., "Novel Metal Nanostructure and 4 <sup>th</sup> -Generation Super-RENS Optical Disk," <i>the European Phase Change and Ovonic Symposium</i> , Switzerland, March 11, 2003, pp. 1-2.

EXAMINER

DATE CONSIDERED

\* EXAMINER: Initial if reference considered, whether or not criteria is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applican(s).